



Status of sensor R&D in Minsk

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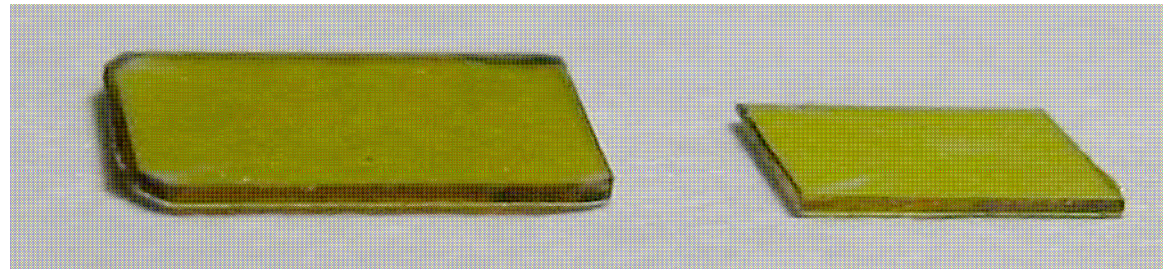


Available technology

Synthetic monocrystalline diamonds produced by “ADAMAS” plant near Minsk (www.bsuproduct.by/index.php/91....1.0.0.html)

The diamond plate size of 5x5 mm area and 200-1000 um thickness
Different catalytic environments and synthesis conditions are investigated in order to reduce the impurity content.

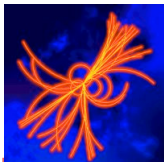
The detectors could be used in beam monitoring and similar applications.



Our institute have the following facilities

CCD measurement setup

Absorption spectroscopy setup (optical)



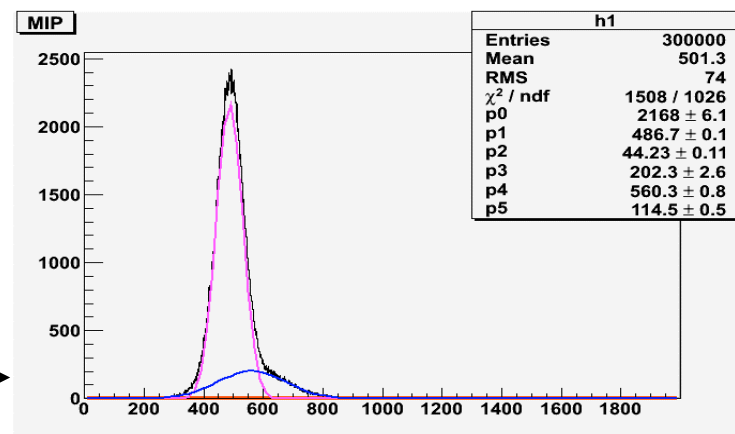
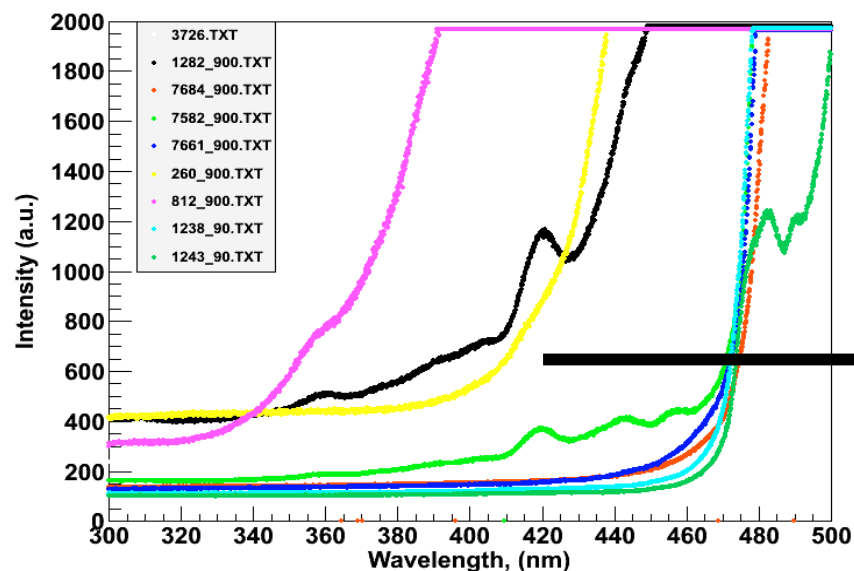
Current work

“Adamas” is working on the optimisation of synthesis process

We are working on establishing the selection criteria to distinguish “detector grade” crystals without cutting and metallisation

Optical absorption spectroscopy

Transparency



CCD \sim 25 μm

Lower N content \rightarrow edge closer to UV \rightarrow better detector properties



Current work

A number of samples were investigated - so far the samples with “good” optical spectrum show CCD above the average
~20 vs < 10 μm

Thermobaric treatment seems to improve the detector properties
At the moment we are investigating this.

A few new crystals were selected on the basis of optical spectra and measured. The best have about 25 μm CCD. We are going to make measurements after the thermobaric treatment.

Investigation of different catalytic environments and their influence





Future work

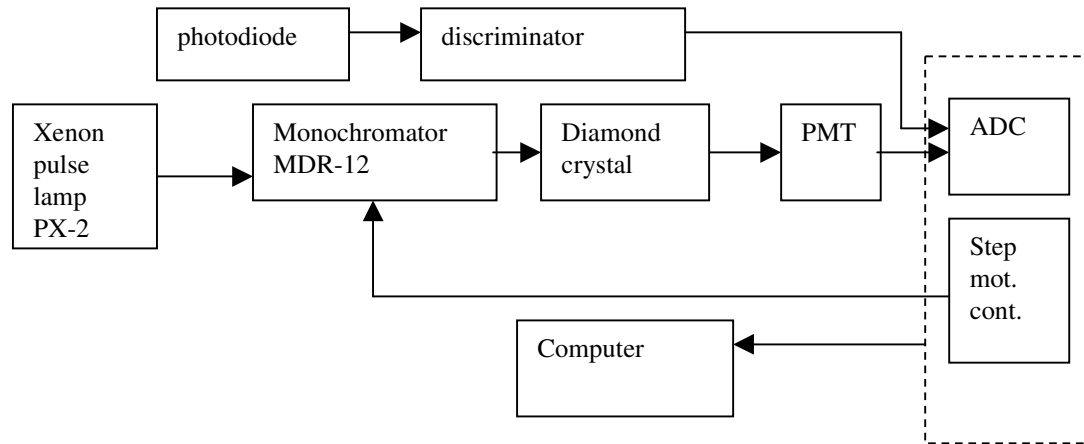
Nitrogen pulse laser will be used for optical fluorescence spectroscopy
This will allow to get more information about impurities and improve the selection process

A number of new synthesis techniques will be tried out by ADAMAS





Absorption setup



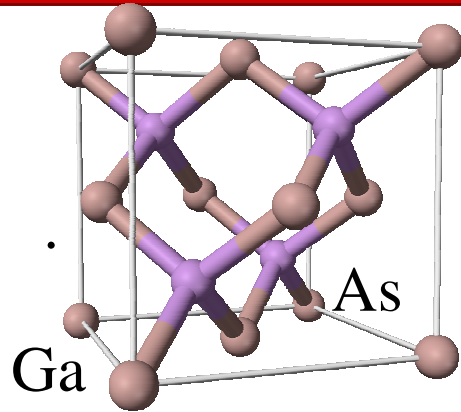


Gallium Arsenide radiation hardness review

K. Afanaciev



The material



Gallium arsenide (GaAs)

Compound semiconductor, direct bandgap

Two sublattices of face centered cubic lattice
(zinc-blende type)

Semiinsulating - no p-n junction

Doped with shallow donor (Sn)
and then compensated with deep
acceptor (Cr) resulting in a I-type
conductivity.

Signal charge transport mainly
by electrons

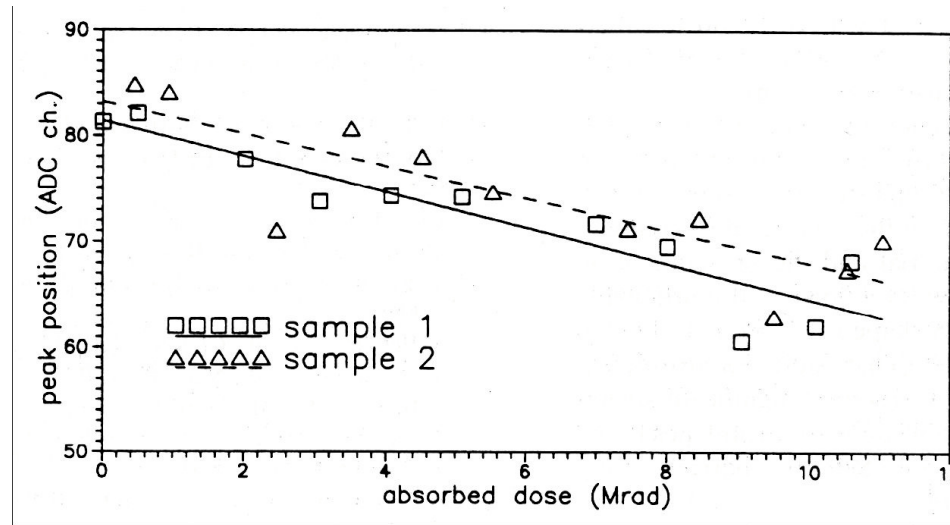
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	GaAs
Density	5.32 g/cm ³
Pair creation E	4.3 eV/pair
Band gap	1.42 eV
Electron mobility	8500 cm ² /Vs
Hole mobility	400 cm ² /Vs
Dielectric const.	12.85
Radiation length	2.3 cm
Ave. E _{dep} /100 μm (by 10 MeV e ⁻)	69.7 keV
Ave. pairs/100 μm	13000
Structure	p-n or insul.



Radiation Tests of Semiconductor Detectors. Valery Chmill PhD Thesis, 2006

Material: Cr and Fe compensated semiinsulating GaAs



Peak position vs dose up to 110 kGy

^{137}Cs – gamma rays, $E = 661 \text{ keV}$

About 20% drop

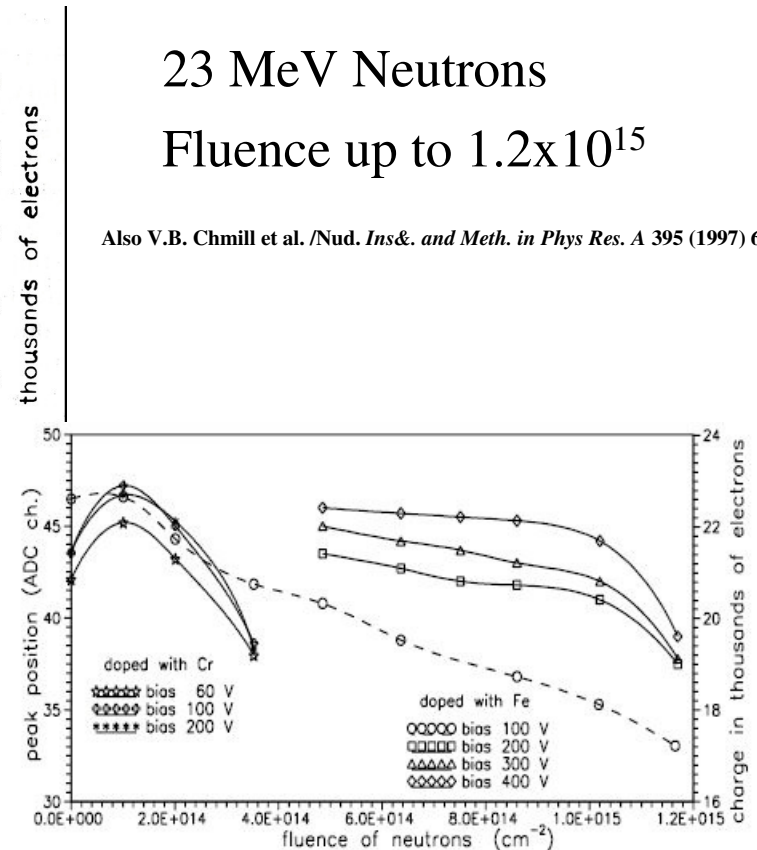


Figure 4.7: Charge collection (spectrum peak position for most probable energy loss) vs. neutron irradiation. The lines are drawn to guide the eye.



Radiation Tests of Semiconductor Detectors. Valery Chmill PhD Thesis

Material: Cr and Fe compensated semiinsulating GaAs

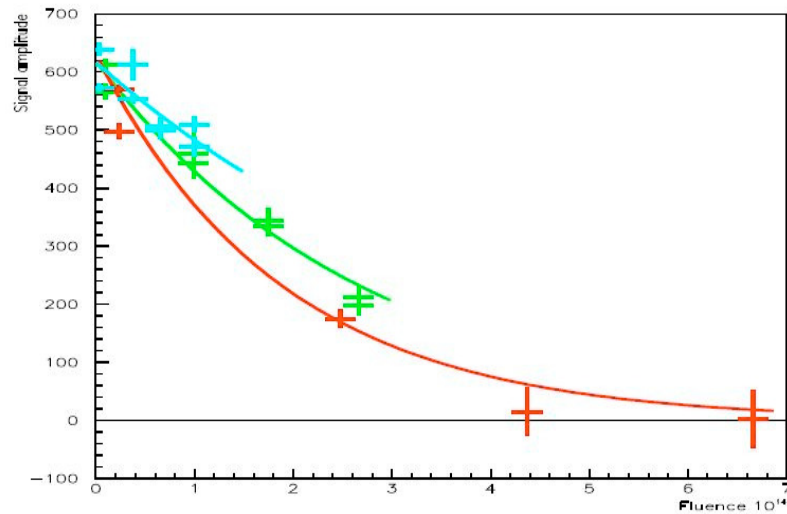


Figure 5.8: The degradation of signal response for bias value 76 V. The three lines correspond to the different positions for the GaAs detectors.

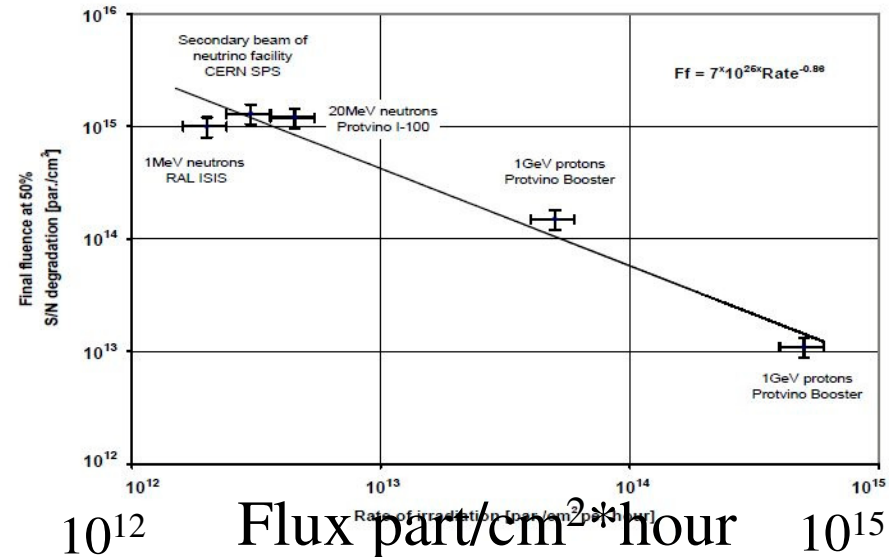


Figure 9.2: Half SNR degradation dependence for different rates of irradiation. Line is drawn as power fit result.

SPS Mixed Beam: 540 GeV protons on beryllium target. Max fluence 7×10^{14}

dose rate ratio 1(red) : 0.32 (green) : 0.16

The dose rate have influence on radiation hardness for hadron irradiation



Radiation resistance study of SI GaAs based radiation detectors to extremely high gamma doses

(*Nuclear Physics B (Proc. Suppl.)* 150 (2006) 402–406)

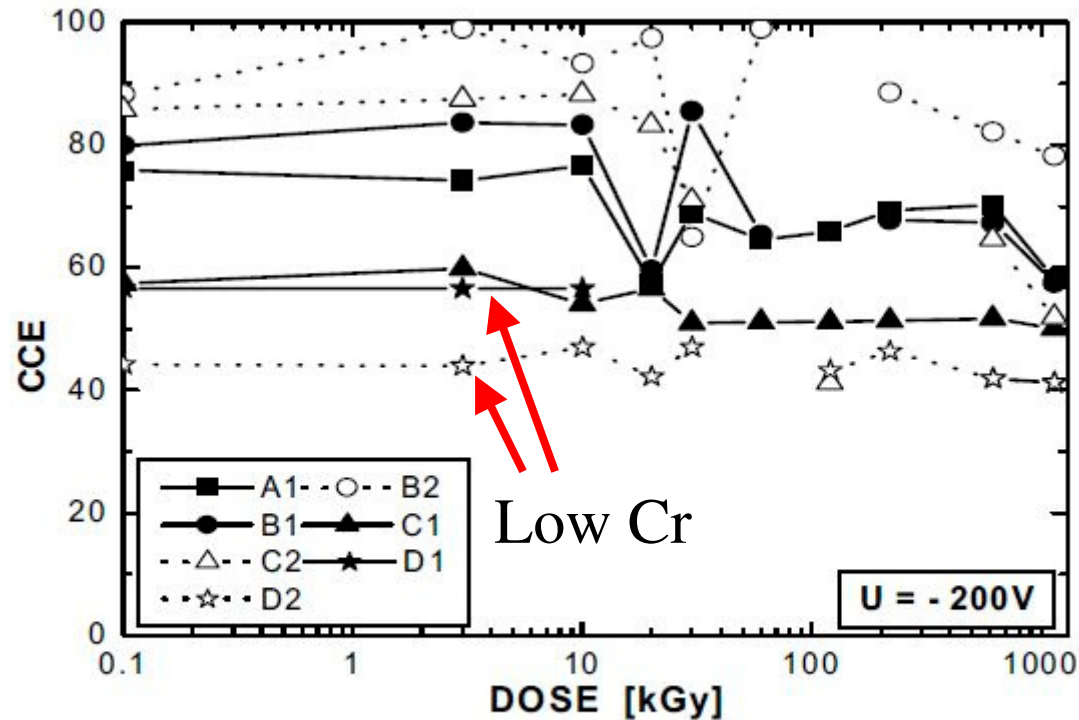


Figure 5: The CCE vs. irradiation dose for all types of samples

LEC semiinsulating GaAs undoped

Irradiation by ^{60}Co gamma source (1.17 and 1.33 MeV photons)



R.L. Bates et al. Recent results on GaAs detectors
(*Nucl. Instr. and Meth. in Phys. Res. A* 392 (1997) 269-273)

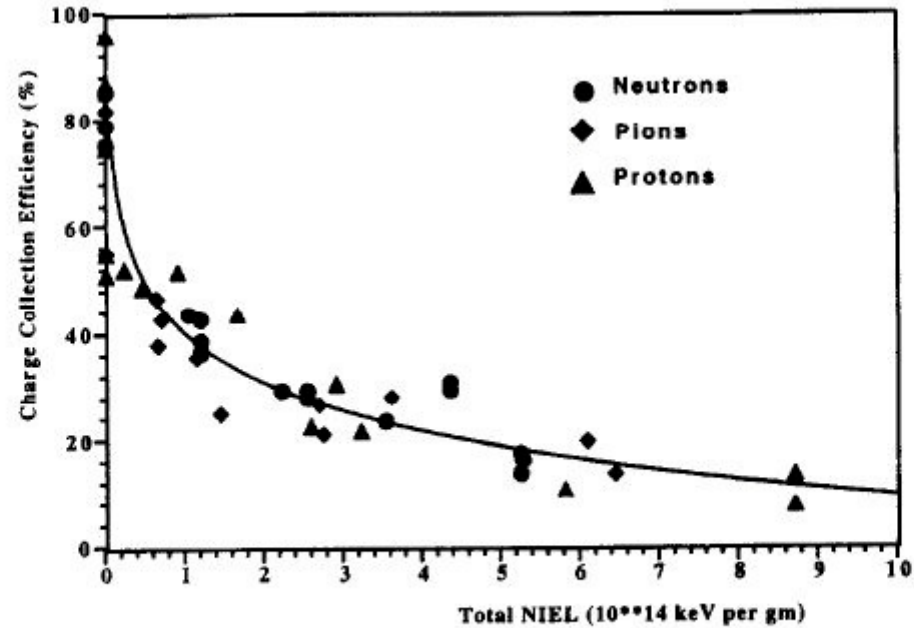


Fig. 4. The charge collection efficiency as a function of total NIEL for ISIS neutrons, 300 MeV/c pions and 24 GeV/c protons for 200 μ m thick SI-U LEC GaAs detectors.

NIEL - non ionising energy loss
LEC undoped GaAs



R.L. Bates *et al* The effects of radiation on gallium arsenide radiation detectors
Nucl. Instr. and Meth. in Phys. Res. A 395 (1997)54-59

neutrons

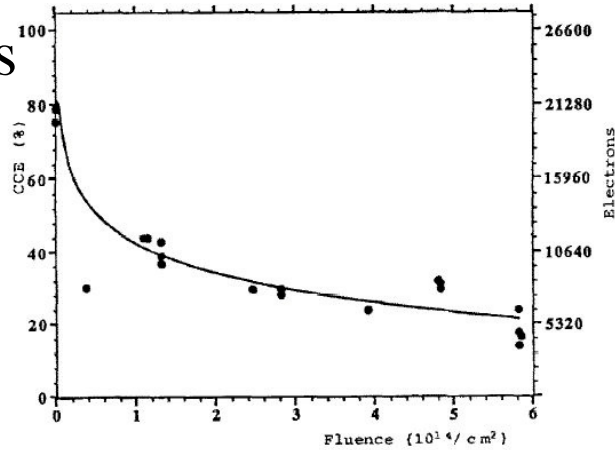


Fig. 5. The cce of 200 μm thick GaAs detectors as a function of neutron fluence, measured at 200 V and 20°C.

pions

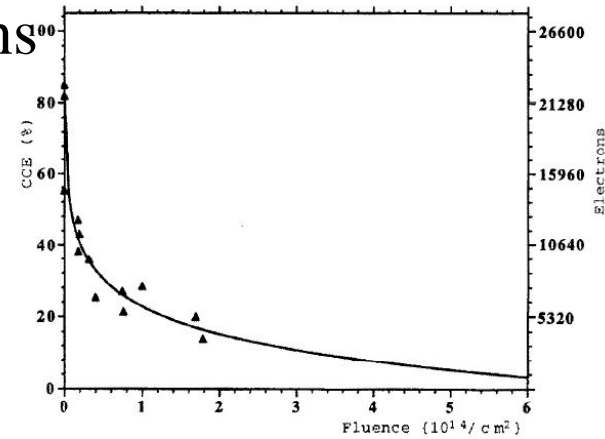


Fig. 7. The cce of 200 μm thick GaAs detectors as a function of pion fluence, measured at 200 V and 20°C.

protons

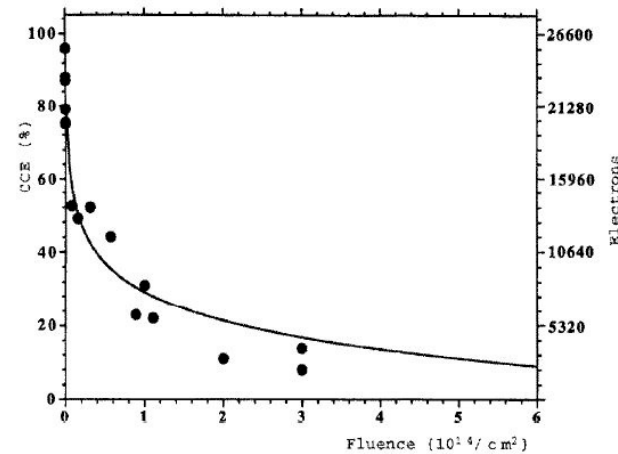


Fig. 6. The cce of 200 μm thick GaAs detectors as a function of proton fluence, measured at 200 V and 20°C.

LEC undoped GaAs